IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815 Examiner: Chris C. CHU

In Re PATENT APPLICATION Of:

Applicant(s): Tadashi YAMAGUCHI

Serial No.:

10/020,153

Filed:

December 18, 2001

For:

SEMICONDUCTOR DEVICE

Docket No.: KAN 137

) INFORMATIO DISCLOSURE) STATEMENT, CERTIFICATION, AND FEE

January 30, 2003

Assistant Commissioner of Patents Washington, D.C. 20231

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(d), i.e., after the mailing of a Final Action and prior to payment of the Issue Fee. Pursuant to 37 C.F.R. § 1.97(e), it is certified that each item submitted with this Information Disclosure Statement was first cited in a Japanese Office Action from the Japanese Patent Office in a counterpart foreign application on November 26, 2002, that is, less than three months prior to filing this Information Disclosure Statement. The fee set forth in § 1.17 (p) is likewise attached.

Attached are copies of six (6) Japanese Patent documents cited within the Japanese Office Action. Any relevance of the foreign-language documents can be gleaned from the attached English-language Abstracts. The publications are listed on the attached Form PTO-1449.

Consideration of the submitted documents is respectfully requested.

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Robert H. Berdo, Jr. Registration No. 38,075 RABIN & BERDO, PC Customer No. 23995

Telephone: 202-371-8976 Facsimile: 202-408-0924

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